



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q92097

Akemitsu IIDA, et al.

Appln. No.: 10/560,980

Group Art Unit: 1754

Confirmation No.: 3728

Examiner: Timothy C. VANOY

Filed: December 16, 2005

For: GAS PROCESSING METHOD AND GAS PROCESSING APPARATUS UTILIZING  
OXIDATION CATALYST AND LOW-TEMPERATURE PLASMA

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 3, 2007, please amend the above-identified application as follows on the accompanying pages.

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